

Docket No.: 50090-318

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoshifumi TAKATA, et al.

Serial No.: Divisional of

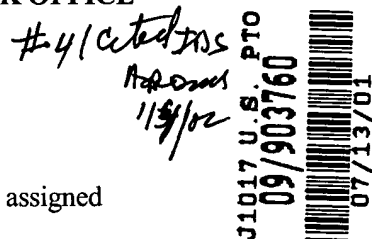
Appln. Serial No. 09/122,650

Group Art Unit: Not yet assigned

Filed: July 13, 2001

Examiner: Not yet assigned

For: A SEMICONDUCTOR DEVICE HAVING AN IMPROVED INTERLAYER CONDUCTOR
CONNECTIONS AND A MANUFACTURING METHOD THEREOF



INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The references were cited by or submitted to the U.S. Patent and Trademark Office in parent application Serial No. 09/122,650, filed July 27, 1998, which is relied upon for an earlier filing date under 35 USC 120. Thus, copies of these references are not attached. 37 CFR 1.98(d).

Respectfully submitted,

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